## Q. Metrology, Inspection, and Yield Enhancement 분과

2020년 2월 14일(금), 09:00-10:30 / Room H (하트 I, 6층)

## [FH1-Q] Nanoanalysis and Characterization

**좌장**: 정용우 박사 (SK하이닉스), 조용재 박사 (한국표준과학연구원)

FH1-Q-1 09:00-09:30	[초청] Spectroscopic Ellipsometric Study on Temperature Dependence Dielectric Functions and
	Critical Point Energies for 2D Materials  Tae Jung Kim <sup>1</sup> , Hoang Tung Nguyen <sup>1</sup> , Van Long Le <sup>1</sup> , Xuan Au Nguyen <sup>1</sup> , Do Hyoung Koo <sup>2</sup> , Chul-Ho Lee <sup>2</sup> , Farman Ullah <sup>3</sup> , Yong Soo Kim <sup>3</sup> , and Young Dong Kim <sup>1</sup>
	<sup>1</sup> Department of Physics, Kyung Hee University, <sup>2</sup> KU-KIST Graduate School of Converging Science & Technology, Korea University, <sup>3</sup> Department of Physics and Energy Harvest Storage Research Center (EHSRC), University of Ulsan
FH1-Q-2 09:30-10:00	[초청] Redefinition of kg Using Kibble Balance and its Application in Semiconductor Metrology Dongmin Kim KRISS
FH1-Q-3 10:00-10:30	[초청] Confocal Thermo-Reflectance Microscope and Applications Ki Soo Chang <sup>1</sup> , Dong Uk Kim <sup>1</sup> , Chan Bae Jeong <sup>1</sup> , Ilkyu Han <sup>1</sup> , Jung Dae Kim <sup>1</sup> , Hyun Hwangbo <sup>1</sup> , Seung-Woo Lee <sup>2</sup> , and Byung-Seon Chun <sup>2</sup> <sup>1</sup> Division of Scientific Instrumentation, KBSI, <sup>2</sup> Nanoscope Systems, Inc.